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# INTERNATIONAL STANDARD

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Semiconductor devices - Micro-electromechanical devices -Part 19: Electronic compasses (standards.iteh.ai)

Dispositifs à semiconducteurs – Dispositifs microélectromécaniques – Partie 19: Compas électroniques d457641419dd/iec-62047-19-2013





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IEC Central Office	Tel.: +41 22 919 02 11
CH-1211 Geneva 20	info@iec.ch
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С	Ο	N٦	ΓE	N	ΤS	5
_	-				-	

FO	REWO	)RD		4
1	Scop	e		6
2	Norm	native re	ferences	6
3	Term	s and d	efinitions	6
4	Esse	ntial rati	ings and characteristics	7
•		Compo	sition of e-compasses	7
	7.1	4 1 1	General	7
		4 1 2	Magnetic sensor section	<i>1</i> 8
		4 1 3	Acceleration sensor section	0 8
		414	Signal processing section	0
		4 1 5	Peripheral hardware section	0
		4.1.6	Peripheral software section	0 8
		4 1 7		0 
	4.2	Rating	s (Limiting values)	9
	4.3	Recom	mended operating conditions	9
	4.4	Electric	c characteristics	9
		4.4.1	General	9
		4.4.2	Characteristics of sensor sections	9
		4.4.3	DC characteristics ANDARD PREVIEW	.10
5	Meas	suring m	ethods	.11
	51	Sensiti	vity of the magnetic sensor section	11
	0.1	5.1.1	Purpose JEC 62047-19:2013	.11
		5.1.2	Circuit's dialoranieh.ai/catalog/standards/sist/3a2c1ff4-0742-4469-93cb-	.11
		5.1.3	Principle of measurement	.11
		5.1.4	Precaution to be observed	.12
		5.1.5	Measurement procedure	. 12
		5.1.6	Specified conditions	. 12
	5.2	Lineari	ty of the magnetic sensor section	.13
		5.2.1	Purpose	. 13
		5.2.2	Measuring circuit	. 13
		5.2.3	Principle of measurement	.13
		5.2.4	Precaution to be observed	.13
		5.2.5	Measurement procedure	.14
		5.2.6	Specified conditions	.14
	5.3	Output	of the magnetic sensor section in a zero magnetic field environment	.14
		5.3.1	Purpose	. 14
		5.3.2	Measuring circuit	. 14
		5.3.3	Principle of measurement	. 16
		5.3.4	Precaution to be observed	. 16
		5.3.5	Measurement procedure	. 16
		5.3.6	Specified conditions	. 16
	5.4	Cross	axis sensitivity of the magnetic sensor section	. 16
		5.4.1	Purpose	. 16
		5.4.2	Measuring circuit	. 16
		5.4.3	Measuring method 1	. 17
		5.4.4	Measuring method 2	. 18
		5.4.5	Specified conditions	.19

5.5	Sensitiv	vity and offset of the acceleration sensor section	19
	5.5.1	Purpose	19
	5.5.2	Measuring circuit	20
	5.5.3	Principle of measurement	20
	5.5.4	Precaution of measurement	21
	5.5.5	Measurement procedure	21
	5.5.6	Specified conditions	21
5.6	Freque	ncy bandwidth of the magnetic sensor section (analogue output)	21
	5.6.1	Purpose	21
	5.6.2	Measuring circuit	21
	5.6.3	Principle of measurement	22
	5.6.4	Measurement procedure	23
	5.6.5	Specified conditions	23
5.7	Current	consumption	23
	5.7.1	Purpose	23
	5.7.2	Measuring circuit	23
	5.7.3	Principle of measurement	24
	5.7.4	Precaution for measurement	24
	5.7.5	Measurement procedure	24
	5.7.6	Specified conditions	24
Annex A	(informa	tive) Considerations on essential ratings and characteristics	25
Annex B	(informa	tive) Terminal coordinate system of e-compasses	26
Annex C	(informa	tive) Descriptions of the pitch angle, roll angle, and yaw angle with	
drawings		IFC 62047-19/2013	28
Bibliograp	ohy		30
		d457641419dd/iec-62047-19-2013	
Figure 1 -	– Compo	osition of e-compasses	8
Figure 2 -	- Circuit	to measure sensitivity	11
Figure 3 -	- Measu	ring method of linearity	13
Figure 5 -	- Measu	ring circuit using a magnetic shield room or a magnetic shield box	15
Figure 6 -	- Directi	on of DUT	20
Figure 7 -	– Block	diagram of frequency measurement	22
Figure 8	Currer	t consumption measuring circuit	24
		it consumption measuring circuit	
Figure B.		lie terminal coordinate system of magnetic sensors	20
Figure B.:	2 – Tern	ninal coordinate system of acceleration sensors	27
Figure C.	1 – Des	criptions of the pitch angle, roll angle, and yaw angle with drawings	29

Table 1 – (	Characteristics of sensor sections	10
Table 2 – [	DC characteristics of e-compasses	10

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# SEMICONDUCTOR DEVICES – MICRO-ELECTROMECHANICAL DEVICES –

# Part 19: Electronic compasses

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The text of this standard is based on the following documents:

FDIS	Report on voting
47F/156/FDIS	47F/163/RVD

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all parts in the IEC 62047 series, published under the general title *Semiconductor devices* – *Micro-electromechanical devices*, can be found on the IEC website.

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# SEMICONDUCTOR DEVICES – MICRO-ELECTROMECHANICAL DEVICES –

# Part 19: Electronic compasses

# 1 Scope

This part of IEC 62047 defines terms, definitions, essential ratings and characteristics, and measuring methods of electronic compasses. This standard applies to electronic compasses composed of magnetic sensors and acceleration sensors, or magnetic sensors alone. This standard applies to electronic compasses for mobile electronic equipment.

For marine electronic compasses, see ISO 11606.

Electronic compasses are called "e-compasses" for short. Types of e-compasses are: 2-axis e-compasses, 3-axis e-compasses, 6-axis e-compasses, etc., all of which are covered by this standard.

# 2 Normative references iTeh STANDARD PREVIEW

The following documents, in whole or in part, are normatively referenced in this document and are indispensable for its application. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies. IEC 62047-19:2013

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None

# 3 Terms and definitions

For the purposes of this document, the following terms and definitions apply.

# 3.1

# 3-axis Helmholtz coil

three Helmholtz coils that generate magnetic fields at right angles to each other

# 3.2

# zero magnetic field environment

magnetic field environments where magnetic field strength in a space including a device under test is lower than the strength specified

Note 1 to entry: The device under test (DUT) is defined in 4.1.7.

# 3.3

# e-compass

# electronic compass

compass that calculates and outputs an azimuth using the electrical output of sensors

Note 1 to entry: The term "e-compass" is used as an abbreviated term of electronic compass. (See the above Scope.)

# 3.4

# 2-axis e-compass

e-compass that uses a 2-axis magnetic sensor as a geomagnetism detection element

# 3.5

# 3-axis e-compass

e-compass that uses a 3-axis magnetic sensor as a geomagnetism detection element

# 3.6

# 6-axis e-compass

e-compass that uses a 3-axis magnetic sensor as a geomagnetism detection element, and a 3-axis acceleration sensor as an gravity detection element

# 3.7

# magnetic north

direction of the horizontal component of an environment magnetic vector at a location, which is the same direction a compass points to

Note 1 to entry: Geomagnetism is sometimes warped by artificial structures (buildings, vehicles, etc.), or is sometimes affected by their magnetization especially in urban areas. Strictly, therefore, the geomagnetic vector should be called a kind of environmental magnetic vector. Although the environmental magnetic vector does not point to the magnetic north pole exactly, here "magnetic north" is defined as the horizontal component of an environmental magnetic vector.

# 3.8

# true north

direction of the horizontal component of a vector pointing to the North Pole of the Earth (north end of rotational axis) at a location, which is the same as the north to which longitude lines or a meridian point

# iTeh STANDARD PREVIEW

# 3.9

azimuth angle rotational angle around z-axis of a terminal coordinate system, which is defined as zero degree when the xy-plane of a terminal coordinate system is horizontal and the yz-plane includes the North Pole, where a clockwise turn is defined as positive when the z-axis is viewed from the positive direction to the negative direction

Note 1 to entry: Azimuth angle is the same as the yaw angle, see Annex C.

Note 2 to entry: For coordinate systems of e-compasses, see Annex B.

Note 3 to entry: For an explanation with diagrams, see Annex C.

Note 4 to entry: Definitions for cases in which the xy-plane of a terminal coordinate system are not horizontal are under consideration.

#### **Essential ratings and characteristics** 4

#### **Composition of e-compasses** 4.1

#### 4.1.1 General

As shown in Figure 1, an e-compass is composed of the following sections:

- Magnetic sensor section;
- Acceleration sensor section;
- Signal processing section;
- Peripheral hardware sections;
- Peripheral software sections.

In some cases, an e-compass does not contain the acceleration sensor section and/or the peripheral hardware section.



1	Magnetic sensor section
2	Acceleration sensor section
~	Olevel and second and second

3 Signal processing section

Key

Figure 1 – Composition of e-compasses

DUT

Peripheral software section

5

6

# 4.1.2 Magnetic sensor section ITen STANDARD PREVIEW

A magnetic sensor section is a magnetic sensor to measure magnetic fields of an Earth's magnetism level, which measures two or more axes of magnetic fields that are at right angles to each other for calculating azimuth angles using its output.

# IEC 62047-19:2013

In the case of a 3-axis magnetic sensor, for example, the sensor section is composed of an x-axis sensor, a y-axis sensor, and a z axis sensor, and the sensitivity axis of the x-axis sensor is set to the x-axis.

# 4.1.3 Acceleration sensor section

An acceleration sensor section is an acceleration sensor to measure gravity. Vertical direction (horizontal plane) is known from its output, and then an azimuth angle is calculated based on the information with correction considering the attitude of the magnetic sensor section (tilt angle).

In the case of a 3-axis acceleration sensor, for example, the sensor section is composed of an x-axis sensor, a y-axis sensor, and a z-axis sensor, and the sensitivity axis of the x-axis sensor is set to the x-axis.

# 4.1.4 Signal processing section

A signal processing section is a circuit section to drive the sensor section and to amplify its signal. In some cases, this section includes an analog-digital converter.

# 4.1.5 Peripheral hardware section

A peripheral hardware section includes sections of a digital interface, data storage for information to control registers and devices, and an information processing.

# 4.1.6 Peripheral software section

A peripheral software section includes not only a device driver section to acquire data but also software to convert the coordinate data from magnetic sensors and acceleration sensors and to calculate azimuth angles based on the results.

# 4.1.7 DUT

The DUT is a functional composition composed of the magnetic sensor section, the acceleration sensor section, the signal processing section, and the peripheral hardware section. For e-compasses not having the acceleration sensor section and/or the peripheral hardware section, the DUT is a functional composition composed of the magnetic sensor section and the signal processing section. Measurements of ratings and characteristics are made using the DUT.

# 4.2 Ratings (Limiting values)

The following items should be described in the specification, unless otherwise stated in the relevant procurement specifications. Stresses over these limits can be one of the causes of permanent damage to the devices:

- Power supply voltage;
- Input voltage;
- Input current;
- Storage temperature;
- Mechanical shock (requisite for 6-axis e-compasses);
- Maximum magnetic field (can be omitted).

# 4.3 Recommended operating conditions

The following items should be described in the specification, unless otherwise stated in the relevant procurement specifications. These conditions are recommended in order to keep the characteristics of the DUT (the devices) stable state during operation:

- Power supply voltage; IEC 62047-19:2013
- Input voltage: https://standards.iteh.ai/catalog/standards/sist/3a2c1ff4-0742-4469-93cb-
- d457641419dd/iec-62047-19-2013
- Operating temperature.

# 4.4 Electric characteristics

# 4.4.1 General

Electric characteristics specified in this standard are those of sensor sections and DC characteristics. For the selection of essential ratings and characteristics, see Annex A.

# 4.4.2 Characteristics of sensor sections

Characteristics of sensor sections are listed as shown in Table 1.

Deremeter	Mandatory		Value			Measuring	Domorko	
Parameter	wandatory	optional	Min	Тур	Max	method	Remarks	
Measuring time of magnetic sensor (at one time)	x			х		See 5.1	NOTE 1	
Sensitivity of magnetic sensor	х			х		See 5.1	NOTE 1	
Measuring range of magnetic sensor	x		x		x	See 5.1	NOTE 1 NOTE 4	
Linearity of magnetic sensor		х			х	See 5.2	NOTE 1	
Zero magnetic field output of magnetic sensor		х			x	See 5.3	NOTE 1	
Cross axis sensitivity of magnetic sensor		х			x	See 5.4	NOTE 1 NOTE 2	
Frequency range of magnetic sensor (analog output)	x		x		x	See 5.6	NOTE 1	
Measuring time of acceleration sensor (at one time)	x (only 6-axis)			х		See 5.5	NOTE 3	
Sensitivity of acceleration sensor	x (only 6-axis)		x	х	x	See 5.5	NOTE 3	
Measuring range of acceleration sensor	x (only 6-axis)		x		x	See 5.5	NOTE 3 NOTE 4	

# Table 1 – Characteristics of sensor sections

NOTE 1 Measurement at the magnetic sensor section is made using 1 Magnetic sensor section, 3 Signal processing section, 4 Peripheral hardware section and 5 Peripheral software section of Figure 1.

NOTE 2 As there are two types of definitions, describe which one is followed. See 5.4.3.1 and 5.4.4.1 for these two definitions.

NOTE 3 Measurement at acceleration sensor section is performed using 2 Acceleration sensor section, 3 Signal processing section, 4 Peripheral hardware section and 5 Peripheral software section of Figure 1.

NOTE 4 It is specified as the minimum value of the positive direction and the negative direction.

# 4.4.3 DC characteristics

DC characteristics of e-compasses are listed as shown in Table 2.

Table 2 –	DC	characteristics	of	e-compasses
-----------	----	-----------------	----	-------------

Perometer	Mandatory	ontional	Value			Measuring
Farameter	Manuatory	optional	Min	Тур	Max	method
Average current consumption during magnetic field measurement in a described measuring period	x			х		See 5.7
Max. current consumption during measurement		х			х	See 5.7
Current consumption during standby		х		х		See 5.7
Average current consumption during intermittent measurement		х		х		See 5.7

# 5 Measuring methods

# 5.1 Sensitivity of the magnetic sensor section

# 5.1.1 Purpose

To measure the sensitivity of the magnetic sensor section under specified conditions.

# 5.1.2 Circuit diagram



- 6 Power supply for DUT
- 7 3-axis Helmholtz coil
- 8 DUT

Key

1 2

3

4

5

# Figure 2 – Circuit to measure sensitivity

The same configuration is used for analogue output sensors.

# 5.1.3 Principle of measurement

# 5.1.3.1 General

The sensitivity is defined as the output change by application of a magnetic field in the direction of the sensitivity axis of each sensor (x-axis, y-axis, or z-axis sensor) divided by the strength of the magnetic field applied.

# 5.1.3.2 Principle of measurement for sensitivity of x-axis sensor

Sensitivity of the x-axis sensor,  $A_x$ , is given by the following equation:

$$A_{\rm x} = \frac{V_{\rm xp} - V_{\rm xn}}{2H} \tag{1}$$

where

- $A_x$  is the sensitivity of the x-axis sensor, given in V·m/A represented with LSB (Least Significant Bit). 'A' (current), s (time), etc., may be also used as the units;
- $V_{xp}$  is the output of the x-axis sensor at the magnetic sensor section when a magnetic field of strength *H* is applied in the positive direction of x-axis at the magnetic sensor section, and the unit is 'V' represented with LSB;
- $V_{xn}$  is the output of the x-axis sensor at the magnetic sensor section when a magnetic field of strength *H* is applied in the negative direction of x-axis at the magnetic sensor section, and the unit is 'V' represented with LSB;
- H is the magnetic field strength in A/m. (See the note below).

NOTE The magnetic flux density (unit: T) can be used instead of the magnetic field strength, *H*.

# 5.1.3.3 Principle of measurement for sensitivity of y-axis sensor

The principle of measurement for y-axis sensors is as described in 5.1.3.2.

# 5.1.3.4 Principle of measurement for sensitivity of z-axis sensor

The principle of measurement for z-axis sensors is as described in 5.1.3.2.

# 5.1.4 Precaution to be observed

The sensitivity axis of the sensor shall correspond to the direction of the magnetic field of the coil. Measurement for magnetic sensors with analogue output shall be made pursuant to this measurement.

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# 5.1.5 Measurement procedure

# IEC 62047-19:2013

# 5.1.5.1 Measurement procedure of the sensitivity of the x-axis sensor

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The measurement of the sensitivity of the x-axis sensor will be taken as follows.

- a) Set an ambient temperature.
- b) Apply power supply voltage to the DUT, and initialize registers if necessary.
- c) Apply a specified magnetic field in the positive direction of x-axis of the DUT.
- d) Measure the x-axis sensor output of the DUT.
- e) Apply a specified magnetic field in the negative direction of x-axis of the DUT.
- f) Measure the x-axis sensor output of the DUT.
- g) Calculate the sensitivity with Equation (1) using the output value of the x-axis sensor.

# 5.1.5.2 Measurement procedure of the sensitivity of the y-axis sensor

The measurement procedure for the y-axis sensor is as described in 5.1.5.1.

# 5.1.5.3 Measurement procedure of the sensitivity of the z-axis sensor

The measurement procedure for the z-axis sensor is as described in 5.1.5.1.

# 5.1.6 Specified conditions

- Strength of the magnetic field applied;
- Ambient temperature;
- Power supply voltage.

# 5.2 Linearity of the magnetic sensor section

# 5.2.1 Purpose

To measure the linearity of the magnetic sensor section under specified conditions.

# 5.2.2 Measuring circuit

The same circuit as shown in Figure 2 is used.

# 5.2.3 Principle of measurement

The output values of the magnetic sensor are measured against a magnetic field applied. Then, the least square line is plotted from the output values as shown in Figure 3.

Linearity, *L*, is given by the following equation:

$$L = a_{\max}/b \tag{2}$$

where

*L* is the linearity represented in %;

- $a_{max}$  is the maximum of *a*, the difference between the sensor output value calculated for each measuring point and the least squares line;
- *b* is the difference between the maximum and minimum values of the sensor output.



Figure 3 – Measuring method of linearity

# 5.2.4 Precaution to be observed

- When a magnetic field is applied, the strength can be increased from negative to positive, or decreased from positive to negative;
- If there is a difference in the sensor output value between the case the magnetic field is increased and the case it is decreased, evaluation shall be made by applying the magnetic field in both directions (from positive and from negative);
- The range of the magnetic field applied shall be the entire range of the measurement, or a
  particular range of the actual Earth's magnetism.